

PATENT  
0051-0217P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KOJIMA, Tomoyuki et al. Conf.:  
Appl. No.: New Group:  
Filed: January 16, 2004 Examiner:  
For: VACUUM SUCTION SYSTEM AND METHOD OF  
CONTROLLING THE SAME

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 16, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes Amendment to the Specification; and  
Remarks.